

L Number	Hits	Search Text	DB	Time stamp
8	29498	(gate or electrode) and (oxygen with (inert or nitrogen or argon or helium))	USPAT; US-PGPUB	2004/11/16 17:21
9	2274	((gate or electrode) and (oxygen with (inert or nitrogen or argon or helium))) and polysilicon and silicide	USPAT; US-PGPUB	2004/11/16 17:21
10	2107	((((gate or electrode) and (oxygen with (inert or nitrogen or argon or helium))) and polysilicon and silicide) and (oxidizing or thermal or heating or annealing))	USPAT; US-PGPUB	2004/11/16 17:21
11	1757	(((((gate or electrode) and (oxygen with (inert or nitrogen or argon or helium))) and polysilicon and silicide) and (oxidizing or thermal or heating or annealing)) and @ad<20021031	USPAT; US-PGPUB	2004/11/16 17:21
12	386	((((((gate or electrode) and (oxygen with (inert or nitrogen or argon or helium))) and polysilicon and silicide) and (oxidizing or thermal or heating or annealing)) and @ad<20021031) and (side adj wall)	USPAT; US-PGPUB	2004/11/16 17:22
13	77	((((((((gate or electrode) and (oxygen with (inert or nitrogen or argon or helium))) and polysilicon and silicide) and (oxidizing or thermal or heating or annealing)) and @ad<20021031) and (side adj wall)) and (ratio with oxygen)	USPAT; US-PGPUB	2004/11/16 17:22